



Growth and Applications of Oxide Thin Films and Heterostructures

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Message from the Guest Editors

Dear Colleagues,

The aim of this Special Issue is to focus on novel advances, original and innovative studies in various research fields, having in common the possibility of increasing the functionality of devices based on thin oxide layers and/or heterostructures obtained through efficient deposition techniques. Thus, it will bring together new trends in the deposition of thin oxide films by magnetron sputtering, thermal evaporation, and laser, among others, but also new technological paths for obtaining improved heterostructures, focusing on their application side. We welcome papers describing opto-electrical applications based on oxide layers with desired properties from the initial bulk material, as well as combinations of different oxides in controlled heterostructures with macro-engineered properties. Studies can cover different topics, ranging from the relationship between different preparation approaches to the correlation of results obtained from the structural and opto-electrical characterization of films and the functionalization of the target device produced by high-performance deposition.





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Message from the Editor-in-Chief

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